

Appl. No. 10/010,548
Amdt. dated November 26, 2003
Reply to Office Action of August 29, 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**RECEIVED
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NOV 26 2003

APPLICANT: Geun-Young Yeom, et al.) Examiner:
SERIAL NO.: 10/010,548) Tran, Binh X.
FILED: November 8, 2001)
FOR: METHOD OF ETCHING)
SEMICONDUCTOR DEVICE USING)
NEUTRAL BEAM AND APPARATUS)
FOR ETCHING THE SAME)

Art Unit:
1765**OFFICIAL**

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

Applicants respectfully request entry of the following amendment and remarks contained herein in response to the Office Action mailed August 29, 2003. Applicants respectfully submit that the amendment and remarks contained herein place the instant application in condition for allowance.